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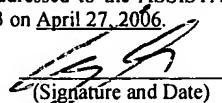
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Dong-Jae Shin et al.
SERIAL NO.: 10/730,568 EXAMINER: Ernest Unelus
DATE FILED: December 8, 2003 ART UNIT: 2828
FOR: METHOD FOR MAINTAINING WAVELENGTH-LOCKING OF FABRY
PEROT LASER REGARDLESS OF CHANGE OF EXTERNAL
TEMPERATURE AND WDM LIGHT SOURCE USING THE METHOD

CERTIFICATE OF MAILING UNDER 37 CFR §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the ASSISTANT COMMISSIONER FOR PATENTS, P.O. BOX 1450 ALEXANDRIA, VA 22313 on April 27, 2006.

Steve S. Cha, Reg. No.:44,069
(Name of depositor)



(Signature and Date)

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Alexandria, Virginia 22313

Sir:

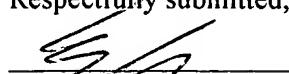
INFORMATION DISCLOSURE STATEMENT

In accordance with Applicant's and Applicant's representatives' Duty of Disclosure under 37 CFR § 1.56, and pursuant to 37 CFR §1.97(d) and MPEP 717.05(b), Applicant(s) submit herewith documentary information for consideration by the Examiner. Information herein cited is only set forth in fulfillment of Applicant's duty of candor in disclosing all information brought to his attention, and is not an admission that it can be used adversely. The publications forwarded herewith are listed on the enclosed Form PTO-1449. Applicant(s) request that the Examiner, upon reviewing the enclosed materials, initial the enclosed form and return a copy thereof in accordance with the instructions on the form.

Applicant further note that each item of information contained in the enclosed Form was first cited from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the statement.

Enclosed please find copies of 2 Foreign Patents & 1 Article listed on the attached Form PTO-1449.

Respectfully submitted,



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Form PTO-1449 IRSY. 7.801 U.S. Department of Commerce Patent and Trademark Office	ATTORNEY DOCKET NO.	5000-1-485
	SERIAL NO.	10/730,568
LIST OF DOCUMENTARY INFORMATION CITED BY APPLICANT (Use several sheets if necessary)	APPLICANT	Dong-Jae Shin et al.
	FILING DATE	December 8, 2003
	GROUP	2828

U.S. PATENT DOCUMENTS

EXAMINE R INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO
	AA	2002-270949	9/20/02	Japan	H01S	5/065	X
	AB	2002-525879	8/13/02	Japan	H01S	5/14	X

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AC	KIM, HYUN DEOK et al.; "A Low-Cost WDM Source with an ASE Injected Fabry-Perot Semiconductor Laser, IEEE Photonics Technology Letters, Vol. 12, No. 8 (2000) 4 pgs.	

EXAMINER:

DATE CONSIDERED:

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609;
Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.